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**AUG 26 2005**

**METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER  
CRYSTALLIZATION PROCESS**

Appl. No. : 10/604,687 Confirmation No. 1686  
Applicant : Kun-chih Lin  
Filed : August 11, 2003  
TC/A.U. : 2822  
Examiner : Guerrero, Maria F  
Docket No. : ADTP0067USA0  
Customer No. : 27765

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450

**AMENDMENT**

Sir:

- 5 In response to the Office action of 06/14/2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.

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